

RECEIVED  
CENTRAL FAX CENTER

AUG 30 2007

Reply under 37 C.F.R. 1.116  
Expedited Procedure  
Technology Center 2822

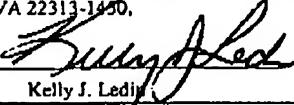
Confirmation No. 9412

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	HIZEN	Examiner:	Duong, Khanh B.
Serial No.:	10/538,217	Group Art Unit:	2822
Filed:	June 9, 2005	Docket No.:	NT.021418 US
Title:	METHOD OF MANUFACTURE OF A TRENCH-GATE SEMICONDUCTOR DEVICE		

CERTIFICATE UNDER 17 CFR 1.8: The undersigned hereby certifies that this correspondence and the papers, as described hereinabove, are being transmitted via facsimile-Formal Entry, to the attention of the Examiner at Commissioner for Patents, MAIL STOP AF, P.O. Box 1450, Alexandria, VA 22313-1450, on August 30, 2007.

By:   
Kelly J. Ledi

Facsimile No.: 571 273-8300

FINAL OFFICE ACTION RESPONSE

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Customer No.  
**65913**

Dear Sir:

In response to the final Office Action dated July 17, 2007, please consider the following amendments and remarks.

A complete listing of the Claims begins on page 2 of this paper.

Remarks/Arguments follow on page 5.

Authorization is given to charge/credit Deposit Account 50-0996 (NXPS.239PA) all requisite fees/overages to enter this paper.